



09-04-03

Attorney Docket No.: 002818/X1/PDD/PSI/JW

2813  
PATENT

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Suketu A. Parikh ) Group Art Unit: 2813  
Serial No.: 09/244,788 ) ) Examiner: Pham, T.S.  
Confirmation No.: 4159 ) )  
Filed: 2/5/99 ) )  
For: Dual Damascene Misalignment Tolerant ) )  
Techniques For Vias And Sacrificial ) )  
Etch Segments ) )

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an **AMENDMENT AND RESPONSE** in the above-identified application, in response to the Office Action mailed 4/14/03. The fee has been calculated as shown below.

	(Col.1)		(Col.2)		(Col.3)	
	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NUMBER PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL	21	MINUS	23	0	\$18.00	\$0.00
INDEPENDENT	3	MINUS	4	0	\$84.00	\$0.00
FIRST	PRESENTATION	OF	MULTIPLE DEPENDENT	CLAIM		TOTAL . . \$0.00..

No additional Filing Fee is required.

Petition to extend time to respond.

Extension Fee \$410.00

The Commissioner is hereby authorized to charge \$410.00 to Deposit Account 50-1074

The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account No. 50-1074. A duplicate of this transmittal is enclosed.

Please address all correspondence to: PATENT COUNSEL  
APPLIED MATERIALS, INC.  
Legal Affairs Department  
P.O. Box 450 A  
Santa Clara, CA 95052

I hereby certify that this correspondence is being  
Deposited with the United States Postal Service as  
Express Mail in an envelope addressed to: Commissioner  
For Patents, P.O. Box 1450, Alexandria, VA 22313-1450

Express Mail Receipt No. EV34110202 US

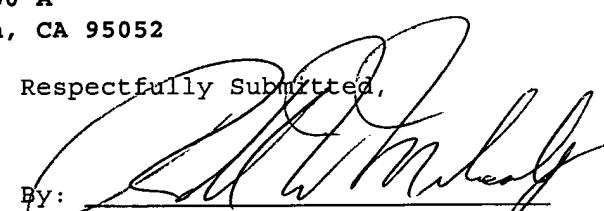
Date of Deposit SEPT. 2, 2003

Signature: Emmanuel

RECEIVED  
SEP 12 2003  
TC 1700

RECEIVED  
SEP - 8 2003  
TECHNOLOGY CENTER 2800

Respectfully Submitted,

By:   
Robert W. Mulcahy  
Registration No.: 25,436

Dated: 09/02/03



#27/D(NE)

PATENT

Attorney Docket No.: 002818/X1/PDD/PSI/JW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Suketu A. Parikh

Serial No.: 09/244,788

Confirmation No.: 4159

Filed: 2/5/99

For: Dual Damascene Misalignment  
Tolerant Techniques For Vias And  
Sacrificial Etch Segments

) Group Art Unit: 2813  
 ) Examiner: Pham, T.S.  
 )  
 ) Amendment and Response to Office  
 ) Action Mailed 4/14/03  
 )  
 ) PATENT COUNSEL  
 ) APPLIED MATERIALS, INC.  
 ) Legal Affairs Department  
 ) P.O. Box 450 A  
 ) Santa Clara, CA 95052  
 )

Commissioner For Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

RESPONSE

RECEIVED  
SEP 12 2003  
TC 1700

This response concerning the above-identified application is in response to the Office Action mailed on April 14, 2003.

RECEIVED  
SEP -8 2003  
TECHNOLOGY CENTER 2800